



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 19, 2026	
IGI Report Number	LG838612952
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL MODIFIED BRILLIANT
Measurements	8.63 X 5.82 X 3.97 MM

GRADING RESULTS

Carat Weight	1.50 CARAT
Color Grade	FANCY YELLOW
Clarity Grade	VVS 2

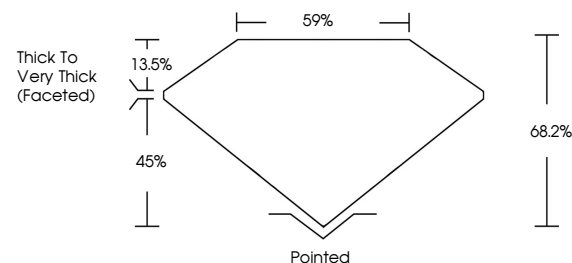
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	131 LG838612952

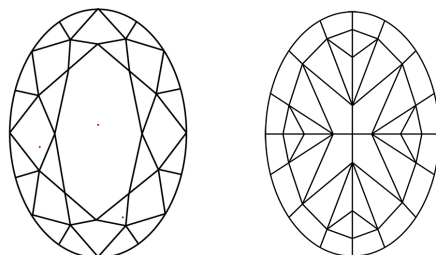
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

LG838612952
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

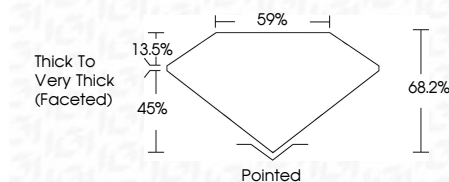
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September 19, 2026
GI Report No LG838612952
OVAL MODIFIED BRILLANT

1.50 CARAT	
FANCY YELLOW	
VS 2	
68.2%	
59%	
Thick To Very Thick (cascaded)	
Pointed	
EXCELLENT	
EXCELLENT	
NONE	
gem/carat/1050	

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition

www.igi.org